# SUBD+U. CHPELOOL

JC14 Rec'c. CT/PTO 19 DEC 2001 DOCKET NUMBER FORM PTO-1390 IMERICE PATENT AND TRADEMARK OFFICE HE DEDARTMENT 35-227 (REV 11-2000) TRANSMITTAL LETTER TO THE UNITED STATES own sees 7 C DESIGNATED/ELECTED OFFICE (DO/EO/US) unknown CONCERNING A FILING UNDER 35 U.S.C. 371 PRIORITY DATE CLAIMED INTERNATIONAL APPLICATION NO. INTERNATIONAL FILING DATE 21/06/2000 21/06/1999 PCT/FP00/05758 TITLE OF INVENTION DETECTOR MODULE FOR AN X-RAY DETECTOR SYSTEM APPLICANT(S) FOR DO/EO/US HANSEN, K. et al. Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information: This is a FIRST submission of items concerning a filing under 35 U.S.C. 371. This is a SECOND or SUBSEQUENT submission of items concerning a filing under 35 U.S.C. 371. This is an express request to begin national examination procedures (35 U.S.C. 371(f)). The submission must include 3. .\⊠ items (5), (6), (9) and (21) indicated below. The U.S. has been elected by the expiration of 19 months from the priority date (Article 31). A copy of the International Application as filed (35 U.S.C. 371(c)(2)). is attached hereto (required only if not communicated by the International Bureau). has been communicated by the International Bureau. h. is not required, as the application was filed in the United States Receiving Office (RO/US). An English language translation of the International Application as filed (35 U.S.C. 371(c)(2)). · 🔲 6 а is attached hereto. has been previously submitted under 35 U.S.C. 154(d)(4). h Amendments to the claims of the International Application under PCT Article 34. 7 |X|are attached hereto (required only if not communicated by the International Bureau). have been communicated by the International Bureau. b. have not been made; however, the time limit for making such amendments has NOT expired. c П J<sub>d.</sub> have not been made and will not be made. An English language translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371(c)(3)). An oath or declaration of the inventor(s) (35 U.S.C. 371(c)(4)). 9 A English language translation of the annexes of the International Preliminary Examination Report under PCT 10. П Article 36 (35 U.S.C. 371(c)(5)). Items 11 To 20 below concern document(s) or information included: An Information Disclosure Statement under 37 C.F.R. 1.97 and 1.98. 11 П An assignment document for recording. A separate cover sheet in compliance with 37 C.F.R. 3.28 and 3.31 is included. 12 П A FIRST preliminary amendment. 13 A SECOND or SUBSEQUENT preliminary amendment. 14 15 П A substitute specification. 16 A change of power of attorney and/or address letter. A computer-readable form of the sequence listing in accordance with PCT Rule 13ter.2 and 35 U.S.C. 1.821-1.825. 17. A second copy of the published international application under 35 U.S.C. 154(d)(4). 18 A second copy of the English language translation of the international application under 35 U.S.C. 154(d)(4). 19

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#### Detector module for X-ray detector system

The invention relates in general to a detector module for an X-ray detector system for use in X-ray holography and X-ray spectroscopy with atomic resolution as well as a modular X-ray detector system for the above applications in which such detector modules are used.

Since the invention of holography in 1948, work has been carried out on the application of the holography principle to the three-dimensional representation of atomic structures. A possible solution principle is based on the technique of X-ray holography.

In X-ray holography, atoms in a material sample to be examined are excited to fluorescence, and the fluorescence radiation from the material sample is recorded by a detector. The electric output signals of the detector, which reflect the interference field which builds up within the material sample, then give information about the three-dimensional structure of

the examined sample material. For this purpose it is however necessary that the highest possible number of measurements be carried out on the material sample.

In the past few years, clear progress has been made in the development and production of X-ray detectors which are intended to record the fluorescence radiation of the material sample and separate this reliably from the varied background radiation. These detectors must on the one hand be energysensitive, in order to make possible a distinction of the incoming photons according to their energy or the wavelength of the radiation, but on the other hand, make it possible to operate up to such high counting rates that they record some hundreds of thousands of photons per second. For this purpose, in addition to silicon detectors, mostly germanium detectors were used in the past. The latter must however be cooled with liquid nitrogen, which is relatively costly, and are more suited to recording radiation from approximately 10 keV. A further disadvantage in the use of germanium detectors is that the electronics needed to amplify the measurement signals from the germanium detector can only be arranged at a position which is relatively remote from the germanium detector. To couple the germanium detector with the amplification electronics, long connection lines are thus required, which leads to strong interference and to a susceptibility to error. An integration of pre-amplifier stages in the vicinity of the germanium detector has to date not been successful, the costly cooling of the germanium detector representing a major obstacle. In addition, with an integration of the amplification electronics in the vicinity of the germanium detectors, a considerable number of signal lines must be routed away from the germanium detector or from the amplification electronics, which has proved to be an insurmountable obstacle even with smaller detector lines or detector arrays.

Very recently, progress has also been made in the development and production of location- and energy-resolving

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silicon X-ray detectors.s Thus for example, the monolithic integration of highly sensitive drift detector cells with field effect transistors based on high-resistance silicon substrates was achieved. This detector type has already been used as a single-cell detector in the field of X-ray holography.

As mentioned above, it is necessary for X-ray holography that as large as possible a number of measurements of the material sample be carried out. In one of the possible concrete measurement processes (measurement process 1), this means that a large number of measurements of the fluorescence radiation of the sample are carried out above the material sample over the solid angle region of a hemisphere above the material sample with an angular resolution in the degree range. With these measurements, it is necessary when using single-cell detectors to displace the detector, by means of a mechanically complex and costly displacement structure, stepwise along various tracks on the semi-spherical surface above the material sample. To be able to detect the characteristic lines within the spectrum with the required accuracy, approximately 2.106 entries per solid angle element are for example required. Up to an event rate of approximately 150 kHz, the lines can be determined without major adverse effect on their width. As, for example, 7200 recordings at different solid angles may be required for a complete hologram, a total measurement time of some 24 hours results.

In a second concrete measurement process (measurement process 2) of X-ray holography, the required angular resolution is achieved through different arrival angles of monochromatic X-ray light. An angular resolution of the fluorescence radiation of the sample and thus a displacement of the detector is not required. Due to the abovementioned event-rate

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limitation of single-cell detectors, the same total measurement time results

It is possible to shorten the long total measurement time by using multi-cell detectors instead of a single-cell detector. Through simultaneous measurement of different angle regions (measurement process 1) or the event rate correspondingly multiplied in the case of multi-cell detectors, (measurement process 2), the total measurement time is reduced approximately the factor of the number of detector elements. Due to the limited number of cells or elements, all commercial multigermanium detectors neither make costly displacement structures superfluous in measurement process 1 nor make possible a measurement time reduction to less than approximately one hour (both measurement processes). This reduction in measurement time is regarded as insufficient, as both (synchrotron) radiation sources and the detectors are subjected to fluctuations during long-time operation. The material sample itself can also change during this long measurement, for which reason real-time recordings are ideally desired.

In addition to the detailed example of X-ray holography presented here, detectors for X-ray radiation are used in many other measurement methods, for example in X-ray absorption spectroscopy, X-ray diffraction, X-ray fluorescence analysis and many more fields. For reasons comparable with those mentioned above, commercial silicon and germanium detectors limit the measurements in many applications (for example in synchrotron radiation sources) due to the maximum possible event rate of the detectors or the achievable angle or location resolution.

In US 5,041,729, a multi-cell radiation detector is disclosed in which a number of detector elements is arranged in the form of a line. The radiation detector contains a scintillator on the rear side of which 12 lamellar photodiodes

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are arranged in the form of a line alongside each other. A holder is attached to the photodiodes by means of an isolating adhesive so that all 12 photodiodes are covered and an end section of each photodiode is exposed for wiring. The holder consists of a ceramic insulator and is equipped on its rear side with signal lines for each element. The bond-connection surface of each photodiode is connected by a wire bond to the signal lines. The disadvantage of this design is that only a detector line – but not a detector array – can be produced as the type of wiring allows exclusively a linear arrangement of the detector elements. When using a detector line however, a very long measurement time is required. In addition, the detector line must be displaced stepwise by means of a mechanically complex and costly displacement structure to carry out a complete recording.

It is therefore the object of the invention to provide a detector system with the help of which the above-mentioned disadvantages of the state of the art are overcome. It is in particular the object of the present invention to provide a detector module with a two-dimensional arrangement of detector elements forming a detector array including the corresponding wiring technique, the simultaneous recording of X-ray light being possible via a location or angular resolution, so that for example in X-ray holography, the otherwise customary

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displacement structure is superfluous. A further object of the invention is to make possible a high total event rate of the detector system so that the measurement time is clearly reduced for the same quality of the measurement results, or the quality of the measurement results is increased for the same measurement time.

A detector module with the features of patent claim 1 serves to achieve these objects, and also a detector system constructed from such detector modules with the features of patent claim 29. Advantageous versions of the detector module and of the detector system are the subject of the associated dependent claims.

The basic idea of the present invention is to arrange several detector modules, each containing a number of detector elements, around the material sample to be examined, roughly in the form of a hemisphere. On the basis of such a detector arrangement, significantly shorter measurement times and even the generation of real-time images is possible.

This arrangement of detector elements leads, however, due to the high necessary density of the detector elements, to subsequent problems with regard to the contact between the detector elements and the cooling of the detector modules or of the associated signal-processing electronics. In the case of the detector module according to the invention, detector cells are used which are provided with integrated pre-amplifier electronics on the silicon substrate. As a result, although the length of the signal line tracks between the detector element and the pre-amplifier step is reduced, which leads to a marked reduction in interference, the number of signal lines which must be routed away from the detector element/pre-amplifier arrangement is simultaneously increased.

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The arrangement of the detector modules is preferably based on the capped icosahedron structure of  $C_{60}$  fullerene

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(buckyball), in which (as with a football) an internal basic framework in the form of a hemisphere is formed by ten hexagonal detector modules, the five pentagonal holes of which between the hexagonal detector modules are filled by five further detector modules. Either pentagonal detector modules can be inserted into the pentagonal holes or, which is preferable on cost grounds, the pentagonal holes covered by identical hexagonal detector modules.

In a preferred design, the radius of the hemisphere is approx. 3.7 cm. With this design, approx. 900 individual detector elements are provided in total, as a result of which a solid-angle resolution of approx. 4° is achieved. With the capped icosahedron structure, 15 detector modules are required in total, each detector module bearing approx. 60 detector elements. As detector type, silicon detectors are used with which, in contrast to the known germanium detectors, operation is possible at room temperature. Silicon detectors are superior to germanium detectors at low and average energy levels and high counting rates in the resolution. However, each silicon detector element has a power consumption (determined by the transistor integrated therein) of up to approx. 4 mW. so that a power density of up to approx. 80 mW/cm2 results therefrom. It is clear from this that, despite the use of silicon detectors measures to cool the detector elements or the detector modules are required (conventional air, water or Peltier cooling).

As explained above, each detector module preferably contains approximately 60 detector elements which form a detector array in areal, side-by-side arrangement, which essentially has the same hexagonal basic shape as the actual detector module. Due to the necessary low-parasitism coupling of the signal-processing electronics for the processing of the analog signals coming from the individual detector elements (highly sensitive drift detector cells which are monolithically integrated with field effect transistors), these signal-processing electronics must be integrated in the vicinity of

the detector elements or of the detector array. Because of the lower self-heating of the individual detector elements and the clearly higher loss consumption of the components of the signal-processing electronics, a thermal decoupling between the signal-processing electronics and the detector array and also a cooling or a good heat dissipation of corresponding heat flows is necessary. A good heat dissipation is achieved by arranging for housing parts of the module body to consist of a material with good heat-conducting properties, preferably graphite. A thermal decoupling of both heat sources is achieved by arranging for heat flows of the two heat sources to take the shortest possible common tracks. The selection of suitable materials and cross-sections between heat sources and heat sink is based on the respective quantities of the heat flows.

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The local integration or low parasitism coupling of the signal-processing electronics to the detector array preferably takes place with the help of a conductor track carrier which is arranged directly above the detector array. On this conductor track carrier there would theoretically have to be provided a conductor track for each connection of each detector element, each conductor track having a first end contact in the immediate vicinity of the respective detector connection, in order to be connected to same by a bonding wire, and a second end contact which is located at one end edge of the conductor track carrier, in order to be connected from there to the electronics.

Upon the electric contact between the individual silicon detector elements, in the development presented here with integrated field effect transistor, contact between a total of 6 connections would be necessary for each detector element, and connection with very short bonding wire lengths to the conductor track carrier arranged above the detector elements. In the case of a sensitive surface of approximately 5 mm² for each detector element, a contact with a conventional bonding

wire technique is not possible. In addition, the conductor

tracks lying tightly alongside another would mutually influence one another, which would lead to a marked impairment of the measurement results. This problem is solved according to the invention in that some connections of the detector elements. preferably the sensitive signal conductor connections, are preferably each connected together with a constant-voltagecarrying connection by bonding wires to the conductor track carrier or to the respective first end contacts of the conductor tracks provided on the conductor track carrier. The remaining connections of the detector elements are connected with the help of simple chain bond connections to an external bus structure running in annular fashion around the external edges of the detector array, and via bonding wires through additional bores in the edge area of the conductor track carrier to conductor tracks provided on the conductor track carrier. The number of bond connections which must be guided through bores in the conductor track carrier, and also the number of conductor tracks is clearly reduced as a result. To reduce the undesired reciprocal coupling of the conductor tracks arranged side-by-side on the conductor track carrier. the conductor tracks which are connected to the above constantvoltage-carrying connections are each guided on the conductor track carrier between two signal conductor tracks running sidebv-side.

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coupling between signal lines is determined essentially by the dielectric constant of the carrier material. Ceramic materials such as Al<sub>2</sub>O<sub>3</sub> or else AlN have a dielectric constant higher by roughly a factor of 3 than for example polymers. Therefore, an intermediate layer with a clearly smaller dielectric constant is preferably embedded between the mechanically stable carrier material with a higher dielectric constant and the signal-carrying metallization plane. of this intermediate layer should correspond approximately to the width of a signal-carrying conductor track. As material for the intermediate layer, there can be used in particular benzocyclobutenes or also

polyphenylquinoxalines with a relative dielectric constant of approx. 2.7, but also standard polyimides would be conceivable. A further optimization is achieved by providing the screening conductor tracks located in the metallization plane (detailled description follows) at the same point also in a second rigid metallization plane between the support and dielectric intermediate laver. Compared with the simplest solution, in which the signal lines are developed directly on a ceramic support, the coupling capacity can be reduced by more than a factor of 30, precisely when there are small gaps between the signal lines (for example approx. 50 µm for conductor track widths of approx. 15 um).

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As mentioned at the outset, the basic idea of the present invention is to arrange several detector arrays or detector modules, each containing a number of detector elements, around the material sample to be examined, roughly in the form of a hemisphere. The hemisphere surface is preferably constructed by an arrangement of several areal detector modules each of which contains several detector elements. The individual detector modules are preferably shaped and arranged such that as complete a coverage of the hemisphere surface as possible is achieved. The use of as few different module forms as possible is preferred. A possible variant is to combine four hexagons and five squares into a tetrakaidecahedron. A further preferred variant is to use a capped icosahedron structure of  $C_{60}$ fullerene (buckyball) in which an approximately hemispherical surface is formed from ten hexagons, the five pentagonal free surfaces of which are either closed by suitably inserted pentagons or covered by identical hexagons. With both variants named by way of example, it is preferred to construct the hemispherical surface from identical detector modules, for reason the quadrangular free surfaces of the tetrakaidecahedron or the pentagonal free surfaces of the icosahedron structure are each covered by the hexagonal base modules, as a result of which only one single module type (a hexagonal detector module) is required with both variants. To

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better match the hemispherical surface, it is naturally also possible to use curved detector modules.

In the case of a preferred design of the invention, the abovementioned icosahedron structure is used with which the connections between the individual detector elements and the downstream signal-processing electronics (analog amplifiers etc.) can be kept very short in order to reduce parasitic effects in this manner. The chip(s) which contain the signal-processing electronics are preferably arranged above the detector module and radiometrically screened from the detector array. The connections between the connections of the detector elements of a detector array and the connections of the chips of the signal-processing electronics are produced with the help of a flexible flat cable or a flexible connection film which is led out close to a side edge of the hexagonal detector module.

As already explained above, the preferred detector module has a hexagonal shape and contains approx. 61 connected detector elements. The external edge length of the preferred module is approximately 1.5 cm and the active surface is approximately 3 cm². The proportion of active to passive surface is approximately 50 %, this proportion being dependent on the bonding technique used. In the case of so-called flip-chip contact, a proportion of active to passive surface of approximately 90 % can be achieved. In the case of flip-chip contact, problems can arise due to the different coefficients of thermal expansion of AlN (conductor track carrier) and Si (detector array). A possible solution is the use of silicon also for the conductor track carrier, when a polymer layer for example can then be used as dielectric.

In the case of a preferred sphere radius of the buckyball arrangement of approx. 3.7 cm, an average solid-angle resolution of approx. 4° results. It is apparent that the solid-angle resolution can be increased, while maintaining the detector element surface density, by increasing the hemisphere

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radius. However, the total number of detector elements and consequently also the technical outlay required for the processing of the many data channels, also increases at the same time. The solid-angle resolution can also be increased, while maintaining the hemisphere radius, by a reduction in the active surface per detector element (and consequently by an increase in the detector element surface density), limits being set to this miniaturization by the bonding techniques used.

In the following, the invention is described with reference to the drawings in which:

- Fig. 1 shows an overall view and a detail of the metallization plane of a detector element;
- Fig. 2 shows a view of the chain-bonded detector array (left) and the conductor track carrier (middle) with an array section and also the flexible connection film with a circuit support (right);
- Fig. 3 shows an enlarged representation of the conductor track carrier;
- Fig. 4 shows a perspective view of a fully-assembled
  25 detector module according to the first embodiment of
  the invention; and
  - Fig. 5 shows a cross-section view of a detector module according to a second embodiment of the invention.

The left part of Figure 1 shows the overall view of the metallization plane of an individual detector element, and the right-hand part of Figure 1 shows a detail of this metallization plane. In the centre of the detector element are located drain (D) and also gate and source (S) connections of the monolithically integrated field effect transistor (single-sided junction FET: SSJFET). An internal guard ring (IGR) and a

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substrate connection (IS) divide the transistor spatially from its surrounding. The shaded metal strips represent the electrodes of the closed p-doped troughs of the drift region that lie underneath. The strip potentials are set through a voltage-dividing resistance chain (zig-zag structure). These strip potentials rise from approximately -10 V as the radius increases . A hexagonal detector array preferably has 61 of these detector elements, these 61 detector elements being surrounded by a honeycomb-shaped metallization (see Figure 2) by means of which the individual detector elements are supplied with the highest blocking voltage. The substrate rear side of the individual detector elements is likewise biased and forms the entry window for the photons to be detected.

Figure 2 shows the structure of a detector module with 61 detector elements and the corresponding arrangement of the connections of the detector elements. In the left part of Figure 2 is shown the arrangement of the individual detector elements to form a detector array (for the sake of clarity, only the metallization plane of the cell core with bonding surfaces is shown), in the middle part a conductor track carrier which is arranged in assembled state above the detector array, and in the right-hand part a flexible connection film with a circuit support. The congruence to be achieved is intended to be shown in Figure 2 by the detector section from which it can be deduced that the bores in the conductor track carrier are located above the detector elements in assembled state. As shown schematically in the left-hand part of Figure 2, four of the six respective connections (pads) of a detector element are joined using simple chain bond connections to an external bus structure running around the external edges of the detector array. The connections RD and IS (see left-hand part of Figure 1) lie on a common potential. The bus signals and also the two remaining connections R#1 and S (see left-hand part of Figure 1) are connected via bonding wire connections through a total of 66 bores, the diameter of which is approximately 1.25 mm, to end contact points of respective conductor tracks which are provided on the ceramic conductor track carrier (middle part of Figure 2). The connections R#1 and S of each detector element are guided through the bore lying in each case above the detector element and connected to the associated contact points of the conductor tracks. All conductor tracks on the conductor track carrier open out at one of the six edges of the conductor track carrier (in Figure 2, it is the right-hand edge of the conductor track carrier) and are coupled by wire connections directly or via a flexible connection film to five integrated circuits (front-end chips) which each have 12 analog channels (see right-hand part of Figure 2), where the measurement signals are processed. In addition to the active components, some passive components can also be located on the circuit support.

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3 shows an enlarged representation of conductor track carrier from Figure 2 which is arranged over the detector array in assembled state of the detector module. Clearly to be seen are the bores for guiding the two bonding wires of the two detector connections of each detector element. The bores are in each case arranged in the assembled state of the detector module above an associated detector element. Provided directly at the edge of these bores, on the surface of the conductor track carrier facing away from the detector array, are in each case two end contacts (output signal connection S and supply voltage R#1) of conductor tracks to which the bonding wires starting from the detector connections and guided out through the associated bores are bound. The conductor tracks then run between the other bores in the direction of the right-hand edge of the conductor track carrier where they end in a row of second end contacts to which a flexible connection film or a rigid circuit support can then be connected.

35 The arrangement shown in Figure 3 or the course of the conductor tracks from the first end contact to the second end contact is specified precisely so that the individual conductor

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tracks are very largely decoupled vis-à-vis conductor tracks running nearby. As can also be seen in Figure 3. so-called screening conductor tracks, each of which lies on the fixed potential R#1, run between the individual signal-carrying conductor tracks, each of which is coupled with the output signal connections S.

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Figure 4 shows the overall mechanical structure of the detector module according to the first embodiment of the invention. Shown are the detector array, constructed from the 61 detector elements, with entry windows pointing downwards in Figure 4, and the conductor track carrier arranged above the detector array. The detector array and the conductor track carrier are contained in a hexagonal housing. As explained with reference to Figure 2, four of the six connections of each of the 61 detector elements of the detector array are connected to external bus structure through simple connections. To assemble the detector module, the detector array is first inserted into the housing, glued to this and bonded in the form of a chain. The already-equipped arrangement of conductor track carrier and circuit support is secured above the detector array in the housing, the detector array and the conductor track carrier being a uniform distance from one another. The bonding wires provided for the conductor track connection are then guided through the bores and connected to the two free connections of the individual detector elements. At this point the advantages of the invention become particularly clear, as it is easily recognizable that, of the six connections, contact with only two connections through the bores of the conductor track carrier is necessary. remaining four connections of each detector element are connected by simple chain bond connections, mechanically uncritical, as in the case of this production step, the upper contact surface of the detector array is exposed.

In the case of the design of the detector module shown in

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Figure 4, the front-end chips and further passive components are provided on a circuit support which is connected directly to the conductor track carriers through wire connections provided the connection lines and the circuit are not jointly realized on a common support.

A much more compact construction of the detector module is shown in Figure 5 in which a cross-section of an alternative design of the detector module is shown. As can be seen in Figure 5, the bonded detector array with the downward-pointing radiation entry windows is inserted into a hexagonal housing (or into the base support) and glued to this. The conductor track carrier is inserted into the housing directly above the detector array (and at a uniform distance from it). In this cross-section view can be seen the bores, provided in the conductor track carrier, through which are guided the two bonding wires for each detector element by means of which the two connections of the respective detector element are connected to associated conductor tracks on the conductor track carrier. As can be seen in Figures 2, 3 and 4, also in the case of the design shown in Figure 5, the conductor tracks provided on the conductor track carrier end at an edge of the conductor track carrier and are connected to a flexible connecting film I at their end points or end contacts. The opposed contacts of the connection film I are connected to a separate circuit on which all of the analog signal-processing electronics are provided. The components provided on the circuit support are in general relatively radiation-sensitive and must therefore be screened. This is achieved in the design shown in Figure 5 by providing, above the conductor track carrier, already secured in the housing, a radiation shield above which the circuit support provided with the signalprocessing electronics is arranged. As can be seen clearly in Figure 5, the flexible connection film I, starting from the conductor, is guided laterally through a gap past the radiation shield to the circuit support. The output signals from the circuit support are then guided through a second flexible connection film II through the top II, provided above the circuit support, of the detector module to the outside. This second connection film II serves to couple the detector module with an A/D converter module, the digital signal-processing electronics and a computer which further processes the recorded and pre-processed measurement signals. In the concrete example of holography, in the following a hologram of the atomic structure of the examined material sample is presented on a screen.

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Not only for reasons of better heat dissipation does the housing of the detector module consist for the most part of graphite. The low-energy position of the carbon fluorescence also permits an extension of the sensitive energy range up to values around 300 eV. Furthermore, shaping considerations also argue for the selection of graphite, as graphite, due to its fine-grained structure, can be worked with low production tolerances of under 50 µm. Optionally, various parts of the housing, such as for example the base support or the tops Ia and Ib, can also consist of aluminium or other metals or else industrial ceramics such as aluminium oxide or aluminium nitride (AlN).

Not all photons are absorbed in the silicon volume of the detector array. Instead, the rate of transmitted photons grows with increasing photon energy. In the case of a layered module structure, as shown in Figure 5, the signal-processing electronics can be damaged by this radiation and the module thus put out of operation. Breakdowns caused by radiation damage can be prevented by embedding of the above-mentioned radiation shield above the detector array. Photons absorbed there excite the screening materials to fluorescence radiation, which is superimposed onto the energy spectrum actually to be detected from the sample. As suitable radiation shield materials, chemically stable materials with atoms of high atomic number are suitable, such as for example tantalum or tungsten, to keep the radiation load of the electronics over

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the detector life-span below 1 krad. Between this first layer (for example of tantalum or tungsten) and the detector array, a second layer of a suitable material with atoms of medium atomic number, such as for example titanium, vanadium or chromium, can be provided to absorb the undesired fluorescence of the material of the first layer by absorption processes in the and to prevent them from entering the radiation shield, detector arrav (in the case of tantalum. tantalum fluorescence). In addition, between this second layer and the detector array, a third layer can be provided of a suitable material with atoms of low atomic number, such as for example aluminium, to again keep away the fluorescence of the material of the second layer from the detector array (in the case of titanium, titanium fluorescence). The fluorescence of this third material is also sufficiently absorbed by the carbon of the graphite of which the top is formed (see Figure 5). In the design of the detector module represented in Figure 5, the radiation shield consists of tantalum with a thickness of more than 300 um, titanium with a thickness of more than 50 um and aluminium with a thickness of more than 50 um. Due to the large surface of the radiation shield, a thermal decoupling between radiation shield and the graphite lid lying above it is necessary. For this reason, the region represented in Figure 5 without material between the radiation shield and the graphite lid is preferably filled with a material of low thermal conductivity, such as for example with polymers.

The version of the detector module represented in Figure 5 is particularly suitable for the hemispherical arrangement mentioned at the outset (preferably the capped icosahedron structure of  $C_{60}$  fullerene) around the material sample. A special frame is required for this which, for reasons of better thermal conductivity and screening from external electromagnetic fields and radiation, is made from aluminium. The holder in Figure 5 forms the base element of this frame. In this manner, the individual detector modules can be easily and quickly replaced as required. By using identical, preferably

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hexagonal, detector modules, the production costs of these modules can also be kept low.

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#### Patent claims

- Detector module for X-ray radiation measurement, with
  - a detector array, which has a first surface, facing a radiation source, which is provided with a number of detector elements, and a second surface, facing away from the radiation surface; and
  - a conductor track carrier which is arranged at a distance from the second surface of the detector array and is provided with conductor tracks;
  - first connections of detector elements which are located on the second surface of the detector array being connected to the conductor tracks with the help of bonding wires;
  - the bonding wires of the first connections of the detector elements being guided through bores in the conductor track carrier onto the side of the conductor track carrier facing away from the detector array, to be connected to the conductor tracks which are developed on the surface of the conductor track carrier facing away from the detector array;
  - a bore being provided in the conductor track carrier for each detector element; and
  - the conductor tracks being guided to signal-processing electronics to process the signals coming from the individual detector elements.
- Detector module according to claim 1, in which the detector elements are integrated with amplifier electronics.
- Detector module according to claim 1, in which the detector elements are highly sensitive drift detector cells which are monolithically integrated with field effect transistors.

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- 4. Detector module according to one of the previous claims, in which second connections of the detector elements are connected by simple chain bonding connections at a bus structure provided on the detector array.
- 5. Detector module according to claim 4, in which the bus structure is provided at the external edges of the detector array and the bus lines of the bus structure are connected by bonding wires to conductor tracks developed on the conductor track carrier.
- Detector module according to one of the previous claims, in which the detector array together with the conductor track carrier is mounted in a housing.
- Detector module according to claim 6, in which the housing is made of a material with high thermal conductivity and low X-ray fluorescence capacity.
- Detector module according to claim 6 or 7, in which the housing is made of graphite.
- Detector module according to one of claims 6 to 8, in which the signal-processing electronics are also provided in the housing.
- 10. Detector module according to one of the previous claims, in which the signal-processing electronics are provided on a circuit support which is arranged on the side of the conductor track carrier facing away from the detector array.
- Detector module according to one of the previous claims, in which the signal-processing electronics are screened from

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the radiation source by a radiation shield.

- 12. Detector module according to claim 11, in which the radiation shield is provided between the conductor track carrier and the signal-processing electronics.
- 13. Detector module according to claim 11 or 12, in which the radiation shield has a first layer of a chemically stable material with atoms of high atomic number, such as for example tantalum or tungsten.
- 14. Detector module according to claim 13, in which the first layer of the radiation shield has a thickness of more than 300 um.
- 15. Detector module according to claim 13 or 14, in which, at the side of the first layer of the radiation shield facing the radiation source, a second layer of a material with atoms of medium atomic number, such as for example titanium, vanadium or chromium, is provided.
- 16. Detector module according to claim 15, in which the second layer of the radiation shield has a thickness of more than  $50\ \mu m$ .
- 17. Detector module according to claim 15 or 16, in which, at the side of the second layer of the radiation shield facing the radiation source, a third layer of a material with atoms of low atomic number, such as for example aluminium, is provided.
- 18. Detector module according to one of the previous claims, in which the conductor track carrier is coupled with the circuit support by means of a flexible connection film (I).

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- 19. Detector module according to one of the previous claims, in which the conductor track carrier is coupled with the signal-processing electronics by means of a flexible connection film (II).
- Detector module according to one of the previous claims, which has a hexagonal or pentagonal or quadrangular shape.
- 21. Detector module according to one of the previous claims, in which contact between the detector array and the conductor track carrier is achieved by means of flip-chip contact.
- 22. Detector module according to one of the previous claims, in which an intermediate layer the dielectric constant of which is clearly less than that of the carrier material is provided between the mechanically stable carrier material of the conductor track carrier and the signal-carrying metallization plane of the conductor tracks.
- 23. Detector module according to claim 22, in which the intermediate layer has a thickness which corresponds to approximately the width of a signal-carrying conductor track.
- 24. Detector module according to claim 22 or 23 in which benzocyclobutenes or polyphenylquinoxalines are used as material for the intermediate layer.
- 25. Detector module according to one of claims 22 to 24 in which screening conductor tracks are provided in the metallization plan between the signal-carrying conductor tracks, and in which further screening conductor tracks are also provided at the same point in a second metallization plane between the stable carrier material of the conductor



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track carrier and the dielectric intermediate layer.

#### 26. X-ray detector system, with

- a number of detector modules according to one of claims 1 to 28;
- a frame for holding the number of detector modules on an essentially hemispherical surface around a material sample to be examined;
- the essentially hemispherical surface being formed by a capped icosahedron structure.

#### (12) NACH DEM VERTRAG ÜBER DIE INTERNATIONALE ZUSAMMENARBEIT AUF DEM GEBIET DES PATENTWESENS (PCT) VERÖFFENTLICHTE INTERNATIONALE ANMELDLING

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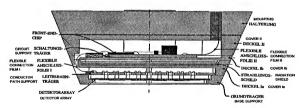
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- (81) Bestimmungsstaaten (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CR, CU, CZ, DE, DK, DM, DZ, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MZ, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TR, TT, TZ, UA, UG, US, UZ, VN, YU, ZA, ZW.

[Fortsetzung auf der nächsten Seite]

(54) Title: DETECTOR MODULE FOR AN X-RAY DETECTOR SYSTEM

(54) Bezeichnung: DETEKTORMODUL FÜR RÖNTGENDETEKTORSYSTEM

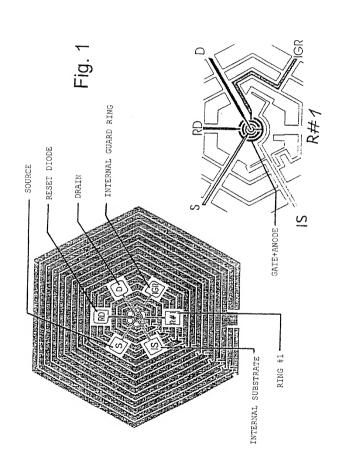


(57) Abstract: The invention relates to a detector module for carrying out an energy-sensitive X-ray measurement. The detector module is equipped with a detector array that comprises a first surface which faces a radiation source and which is provided with a multitude of detector elements, and comprises a second surface which faces away from the radiation source. The detector module is also equipped with a conductor path support which is arranged at a distance from the second surface of the detector ray and which is provided with conductor paths. First connections of the detector elements that are located on the second surface of the detector array are connected to the conductor paths with the aid of bonding wires, and the conductor paths are led to a signal processing electronic unit in order to process the outgoing signals from the individual detector elements.

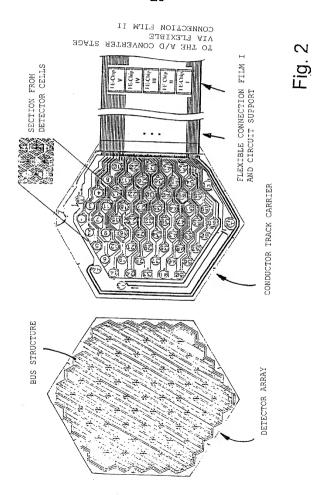
(57) Zusammenfassung: Die Erfindung betrifft ein Detektormodul zur energieempfindlichen Röntgenstrahlmessung, mit einem Detektorarray, das eine erste, einer Strahlungsquelle zugewandte Fläche, die mit einer Vielzahl von Detektorelementen versehen ist, und eine zweite, der Surahlungsquelle abgewandte Fläche aufweist; und einem Leiterbahnträger, der beabstandet von der zweiten Fläche des Detektorarrays sugeordnet und mit Leiterbahnen versehen ist; wobei erste Anschlüsse der Detektorelemente, die sich an der zweiten Fläche des Detektorarrays befinden, mit Hilfe von Bonddräthe mit den Leiterbahnen varienen sind; und wobei die Leiterbahnen zu einer Signalwerarbeitungselektronik geführt sind, um die von den einzelnen Detektorelementen ausgehenden Signale zu verarbeiten.

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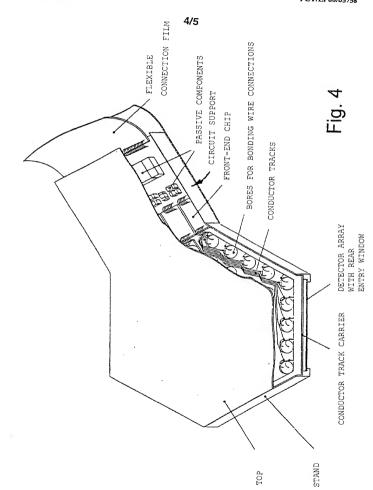
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REPLACEMENT SHEET (RULE 26)



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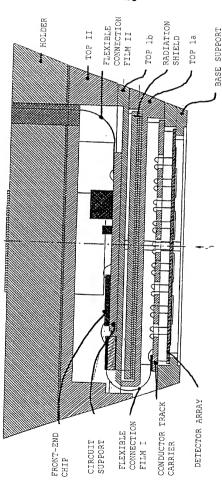


Fig. 5

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# RULE 83 (37 C.F.R. 1.63) INVENTORS DECLARATION FOR PATENT APPLICATION IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

As a below named inventor, I hereby doctare that my residence, mailing address and critizenship are as stated below next to my name, and I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patient is sought on the invention entitled:

DETECTOR MODULE FOR AN X-RAY DETECTOR SYSTEM

The specification of which (check applicable body):

🔲 ls	attached hereto	December 19, 2001	as U.S. Application 5	Cortal Mo		/Δ•	tv Dkt. No. 35-227)
ii w	as filed as PCT Internation		PCT/EP00/05758		21/06/2000		.,
		application) was amended on	11/06/2001		27/00/2000		
I hereby amendm defined i listed bei which pri	state that I have reviews lent referred to above. I n 37 C.F.R. 1.56, I here low and have also identi	ed and understand the contents acknowledge the duty to disclo by claim foreign phority benefit fled below any foreign applicati pnority is claimed, before the fil	s of the above identifie use to the Patent Office s under 35 U.S.C. 119 on for patent or invent	all information k 9/365 of any forei for's certificate ha	(nown to me to be	e materia for caten	to patentability as
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I hereby	claim the benefit under Application Numb	35 U.S.C. §119(e) of any Uniter let	d States provisional s Date/Month/Year Fil		d below.		
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L&BO	Inventors Signature: Inventor;	Larc (first)	E Trigg	THO		To	German (citizenship)
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